

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: TOMINAGA KOJI ET AL. .)
Serial No.: 10/550,805) Group Art Unit: 2813
Filed: July 12, 2006) Examiner: Luke, Daniel M.
For: METHOD FOR FORMING AN) Confirmation No. 3990
INSULATING FILM IN A)
SEMICONDUCTOR DEVICE)

VIA EFS
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT FILED WITH REQUEST FOR CONTINUED EXAMINATION

Sir:

This amendment is respectfully submitted in response to the Final Office Action dated April 30, 2008. Applicants hereby respectfully petition for a one-month extension of time. If there are any charges with respect to this Amendment or otherwise, please charge them to Deposit Account No. 06-1130 maintained by Applicants' attorneys.

Please amend the Application as follows: